

**IN THE UNITED STATES PATENT AND TRADEMARK  
OFFICE**

In re Applicant: § Group Art Unit: 2812  
NGUYEN  
§  
§

Serial No.: N/A §  
§  
§ Examiner: Andre C. Stevenson

Filed: §  
§  
§

For: Removable Lid and § Attorney Docket No. SIM026C  
Floating Pivot §

**PRELIMINARY AMENDMENT**

COMMISSIONER OF PATENTS  
AND TRADEMARKS  
Washington, D.C. 20231

Dear Sir:

Before computing fees, please amend the application as follows:

**In the Claims:**

Please cancel claims 1-26.

Please add the following claims:

27. (New) A semiconductor processing system, comprising:

a chamber adapted to process a wafer, the chamber having an opening to facilitate access to the interior of the chamber;  
a lid coupled to the chamber opening, the lid having an open position and a closed position;

an actuator coupled to the lid to move the lid between the closed position and the open position; and